

10/507245**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Patent Application of)

Masafumi MIYAKAWA et al.)

Application No.:)

Filed: September 10, 2004)

For: PRESSURE-SENSITIVE ADHESIVE)
FILM FOR THE SURFACE)
PROTECTION OF SEMICONDUCTOR)
WAFERS AND METHOD FOR)
PROTECTION OF SEMICONDUCTOR)
WAFERS WITH THE FILM)**DT09 Rec'd PCT/PTO 10 SEP 2004**

Group Art Unit:

Examiner:

Confirmation No.:

FIRST INFORMATION DISCLOSURE STATEMENTCommissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In accordance with the duty of disclosure as set forth in 37 C.F.R. § 1.56, the accompanying information is being submitted in accordance with 37 C.F.R. §§ 1.97 and 1.98.

The listed documents were cited in the International Search Report in the corresponding PCT application.

To assist the Examiner, the documents are listed on the attached form PTO-1449. However, copies of the documents are not provided as it is understood that they have already been transmitted by the International Bureau. It is respectfully requested that an Examiner initialed copy of this form be returned to the undersigned.

Respectfully submitted,

BURNS, DOANE, SWECKER & MATHIS, L.L.P.

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(use as many sheets as necessary)

Sheet	1	of	1
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Complete if Known

Application Number

Filing Date

First Named Inventor

Masafumi Miyakawa et al.

Examiner Name

Attorney Docket Number

018765-171

U.S. PATENT DOCUMENTS

[illegible]

FOREIGN PATENT DOCUMENTS

[illegible]

NON-PATENT LITERATURE DOCUMENTS

Examiner Initials	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.

Examiner Signature		Date Considered	
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*EXAMINER: Initial if reference considered, whether or not citation is in conformance with M.P.E.P. § 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.